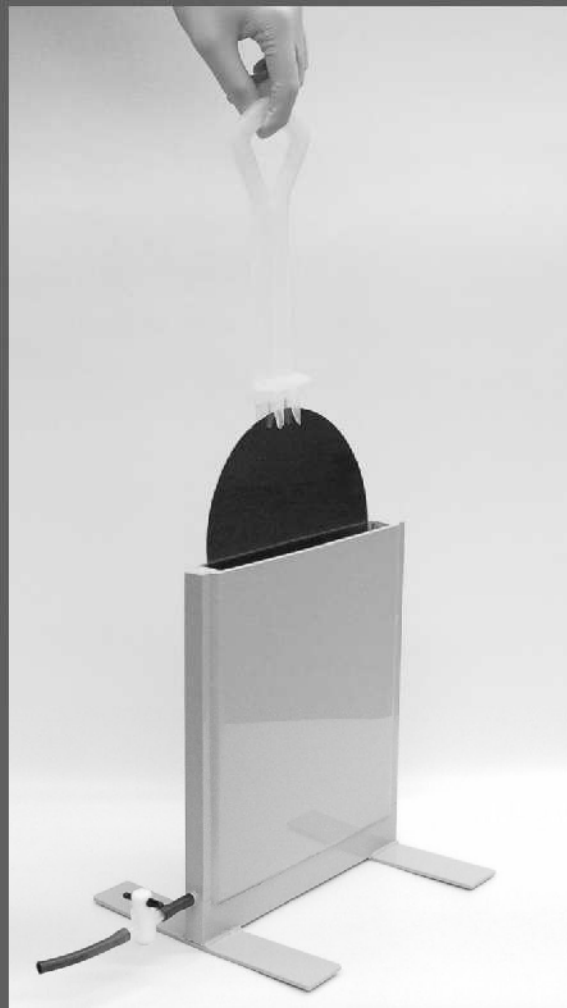


Product Information Brochure



Wet Process Basin

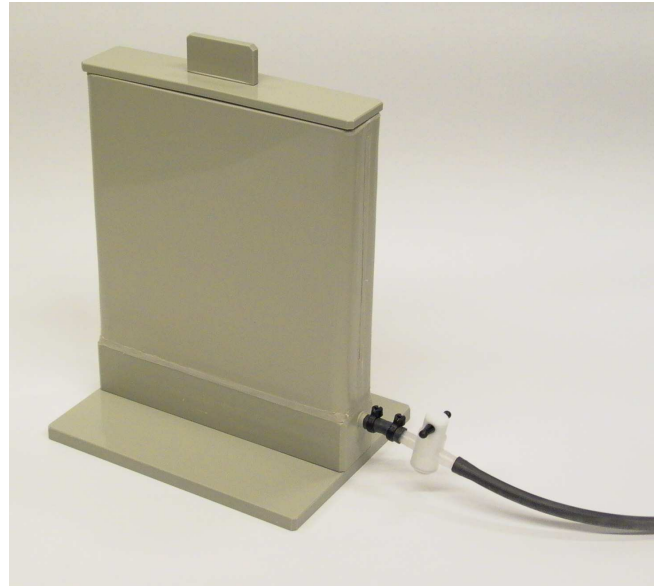
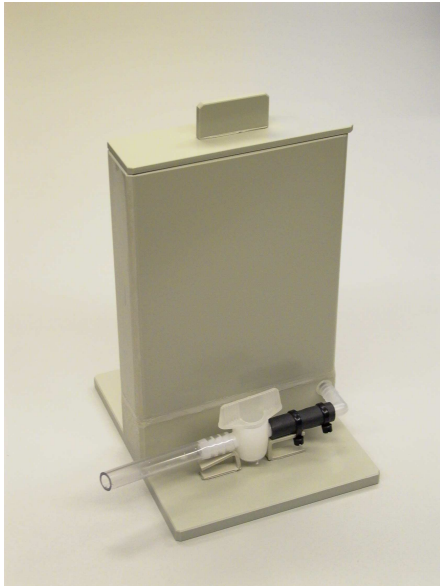
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Wet Process Basin

General Information

Wet processing is a standard fabrication step in MEMS fabrication. Idonus provides custom made basins for wet processing. The product range starts with single wafer basins and goes up to batch process basins adapted for wafer cassette processing. The systems can include heating, bubbling, over-rinse, drains, drying or other specific features.



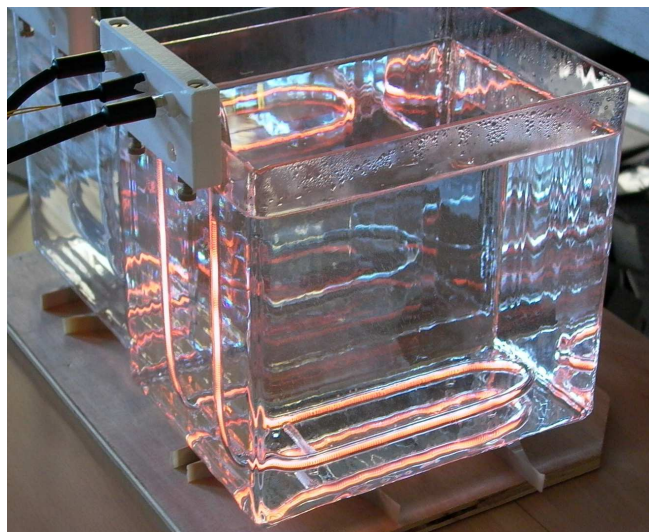
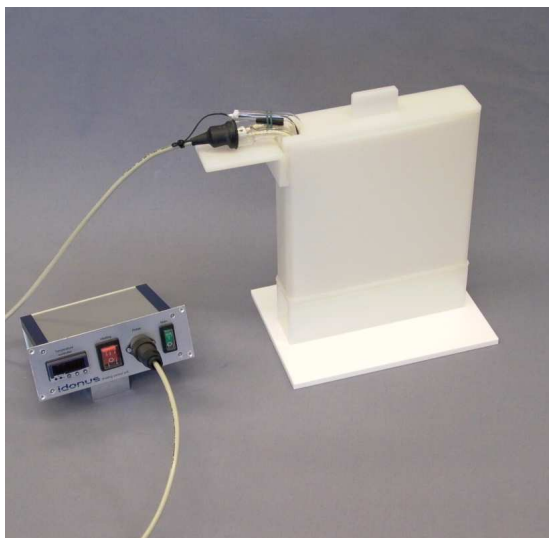
Example of a single wafer basins with lid and drain

Features of Wet Process Basins

- Dimensioned to your substrate size
- Customized e.g. heater, drain, etc.
- Adapted for manual handling
- Made of PP, PVDF or Quartz to resist to your chemicals
- Outside dimension optimized for integration in your wetbench

Wet Process Basin

Technical Specifications



Different basin types with heating and separate controller

Product Code	Wet Process Basin
Substrate sizes	User defined
Materials	PVDF, PP, PTFE, Quartz, etc.
Dimension	User defined, adapted to application and requirements

Contact

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